

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Confirmation No. 7846
Hideaki KUWABARA et al.	)	Group Art Unit: 2826
Application No. 10/579,443	)	Examiner: Scott R. Wilson
Filed: May 15, 2006	)	
For: METHOD FOR FORMING LARGE AREA	)	
DISPLAY WIRING BY DROPLET	)	
DISCHARGE, AND METHOD FOR	)	Date: <u>March 16, 2009</u>
MANUFACTURING ELECTRONIC DEVICE	)	
AND SEMICONDUCTOR DEVICE (AS	)	
AMENDED)	)	

**RESPONSE TO NON-FINAL OFFICE ACTION**

**Mail Stop: AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 15, 2008, Applicants respectfully request reconsideration and allowance of the above-referenced application in view of the following amendments and remarks.